



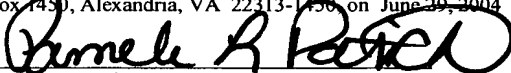
Docket No. 740756-2045

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)
Kenji ITOH et al.) Group Art Unit: 1762
Serial No. 09/412,510) Examiner: M. Padgett
Filed: October 5, 1999)
For: PROCESS FOR TREATING A)
SUBSTRATE WITH A PLASMA)

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on June 29, 2004.


Pamela L. Patrick

REQUEST FOR RECONSIDERATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Applicants response to the Office Action dated March 29, 2004 as follows.